



SPW

**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q80781

Takeyoshi KANO, et al.

Appln. No.: 10/828,472

Group Art Unit: 1774

Confirmation No.: 5352

Examiner: Tamra Dicus

Filed: April 21, 2004

For: PATTERN FORMING METHOD, IMAGE FORMING METHOD, FINE PARTICLE ADSORPTION PATTERN FORMING METHOD, CONDUCTIVE PATTERN FORMING METHOD, PATTERN FORMING MATERIAL AND PLANOGRAPHIC PRINTING PLATE

**RESPONSE TO RESTRICTION REQUIREMENT**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This responds to the Restriction Requirement, dated October 10, 2006, being timely filed on November 13, 2006, as November 10, 2006, was a Federal holiday.

In response to the Restriction Requirement, Applicant elects Group I, claims 1-9, for examination. This election is made without traverse.

Applicant reserves the right to file a Divisional Application directed to non-elected claims 10-19.

The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any

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overpayments to said Deposit Account.

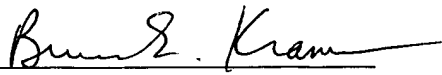
Respectfully submitted,

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WASHINGTON OFFICE

**23373**

CUSTOMER NUMBER

  
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Date: November 13, 2006